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PATENT
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



In re Application of

Fumihito OKA

Application S/N: 09/925,626

Filed: August 10, 2001

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: Group Art Unit: 2811
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: Examiner: S. Hu
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For: CRYSTALLINE SILICON THIN FILM SEMICONDUCTOR DEVICE, CRYSTALLINE SILICON THIN FILM PHOTOVOLTAIC DEVICE, AND PROCESS FOR PRODUCING CRYSTALLINE SILICON THIN FILM SEMICONDUCTOR DEVICE

RESPONSE TO RESTRICTION REQUIREMENT

Honorable Assistant Commissioner
for Patents
Washington, DC 20231

RECEIVED
MAY 28 2002
TC 2800 MAIL ROOM

Sir:

In response to the Official Action dated April 25, 2002, wherein restriction has been required, applicant hereby elects Group I (claims 1-13) for prosecution in the above-identified application without traversal.

Respectfully submitted,

ANTONELLI, TERRY, STOUT & KRAUS, LLP

Alfred A. Stadnicki
Registration No. 30,226

1300 Seventeenth Street
Suite 1800
Arlington, VA 22209
Telephone: (703) 312-6080
Facsimile: (703) 312-6666
E-mail: astadnicki@antonelli.com
Date: May 23, 2002